: ATTN: APPLICATION BRANCH

206379US

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF:

TAKASHI MASATO

SERIAL NO: NEW U.S. PCT APPLN.

(Based on PCT/JP99/05928)

FILED: HEREWITH

FOR: STAGE UNIT, EXPOSURE APPARATUS,

DEVICE MANUFACTURING METHOD,

AND DEVICE

PRELIMINARY AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

SIR:

Prior to a first examination on the merits, please amend the above-identified application as follows:

## IN THE SPECIFICATION

Please amend the specification as shown below. A marked-up copy follows this amendment.

Please replace the paragraph on page 6, lines 2-13, with the following text:

 $Q_{l}$ 

According to the first aspect of the present invention, there is provided a stage unit comprising: a sample stage that holds a sample; a stage diving mechanism that drives the sample stage in at least one direction; a first transmitting member to which at least one part of the stage driving mechanism is connected and a reaction force caused by driving the

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